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October 20, 1997

Exhibit A

Klaus F. Schuegraf
2305 South Grandview Avenue
Tempe, AZ 85282

Re: Docket # 303.278US1 - Micron Ref. No. 96-0732
U.S. Patent Application Serial Number: 08/902,809
Title: SELECTIVE SPACER TECHNOLOGY TO PREVENT METAL OXIDE
FORMATION DURING POLYCIDE REOXIDATION

Dear Klaus:

Enclosed are the documents necessary for execution with regard to the above-identified patent application. Please sign and date the Combined Declaration and Power of Attorney document where indicated. We have also enclosed an Assignment document for notarized execution. Please remember that the Assignment document must be signed and dated in the presence of a Notary Public. Please send back the executed documents to my attention by November 8, 1997 so that we may forward them to the U.S. Patent and Trademark Office for filing.

If you have any questions regarding this matter, please contact me at (612) 373-6904.

Very truly yours,



Daniel J. Kluth

DJK:CMG:dmw
Enclosures

cc: Michael Lynch